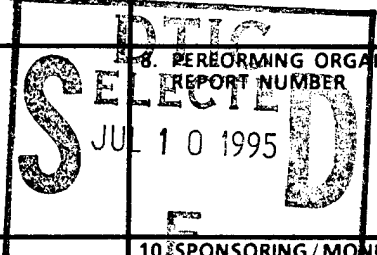


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13. ABSTRACT (Maximum 200 words) The objectives of this work were to develop devices for optical interconnects in the mid-IR, develop devices for mid-IR ranging, IR decoy projection, free space communication, pollution monitoring, and digital optical logic. In addition, it was desired to three dimensional opto-electronic systems with very large scale integrated optics with ultra high confinement waveguides. Advances included the use of quantum wells in the electrode to reduce free electron absorption; use of electrode resonances in the far-IR to reduce penetration of mid-IR light; and use of step wells and dope in barrier to lower linewidth and increase separation of states.				
DTIC QUALITY INSPECTED 3				
14. SUBJECT TERMS mid-IR modulators, ultra high confinement integrated optics, fast opto-electronic quantum well amplitude modulator		15. NUMBER OF PAGES		
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17. SECURITY CLASSIFICATION OF REPORT UNCLASSIFIED	18. SECURITY CLASSIFICATION OF THIS PAGE UNCLASSIFIED	19. SECURITY CLASSIFICATION OF ABSTRACT UNCLASSIFIED	20. LIMITATION OF ABSTRACT UL	

Fast Opto-Electronic Quantum Well Amplitude Modulator

ARPA Contract DAAL03-90-C-0019

Final Report

May 10, 1995

Version 0.0

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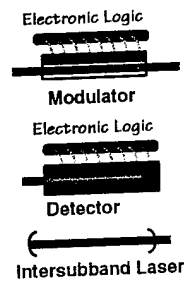
Prepared by

Larry C West
Charlie W. Roberts
Emil C. Piscani
Integrated Photonic Systems Inc.

19950703 319

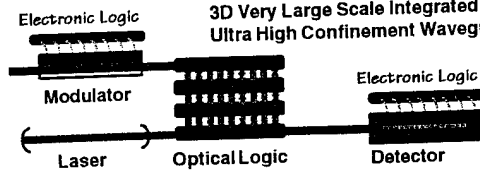
Objectives

Devices:



- Optical Interconnects in mid-IR
 - Less Watts per Quanta Flux
 - > Lower IR Powers
- Mid-IR Ranging
- IR Decoy Projection
- Free Space Communications
- Pollution Monitoring
- Digital Optical Logic

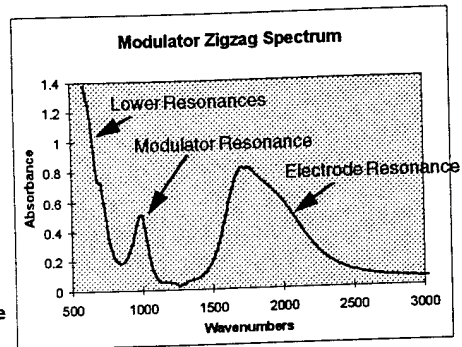
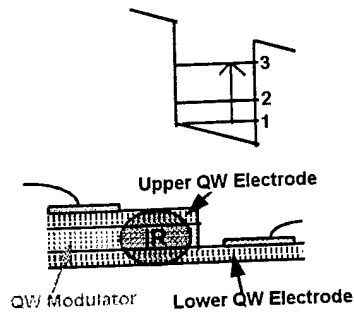
Opto-Electronic Systems:



3D Very Large Scale Integrated Optics with
Ultra High Confinement Waveguides

Modulator Physics

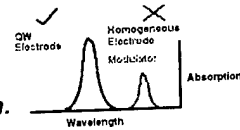
- 1-3 Transition has been isolated from free carrier, and lower level transition absorption.
 - Lower level transitions are narrowed by doping in barriers.
 - Lower level transitions are positioned for minimum loss.
- Free carrier loss has been minimized, while maintaining good electrical properties, using QWs as electrodes
 - Eliminated field exclusion at modulation wavelength by placing the QW electrode resonance at a higher energy than the modulator resonance so it's index is positive.



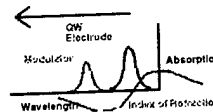
Lessons Learned From Bulk Modulator

- Problem - Solution

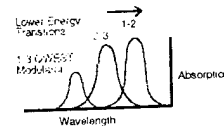
- Free electron absorption is strong in highly doped electrode regions. - *Use QWs in electrode to reduce free electron absorption.*



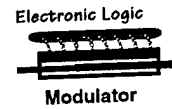
- Electrode resonance in far-IR reduces penetration of mid-IR light (lowers refractive index) - *Resonance must be higher energy than modulator resonance.*



- Lower level transitions can cause residual absorption - *Use step wells and dope in barrier to lower linewidth and increase separation of these states.*

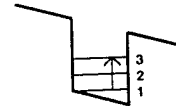


Intersubband Modulation



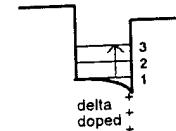
- **Modulator Mechanism**

- Break symmetry with electric fields to allow 1-3 transition.



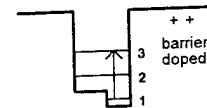
- **A built-in field is created with delta doping on edge of well.**

- Allows observation in spectrometer without application of field.

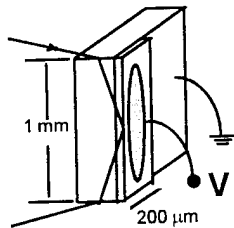


- **Doping outside well allows narrower, stronger lines with less interference from other lines.**

- Use step in Al concentration to create built-in field.



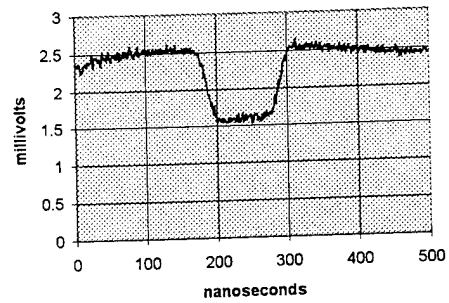
Bulk Modulator



$R = 35 \text{ Ohm}$
 $C = 11 \text{ pF}$

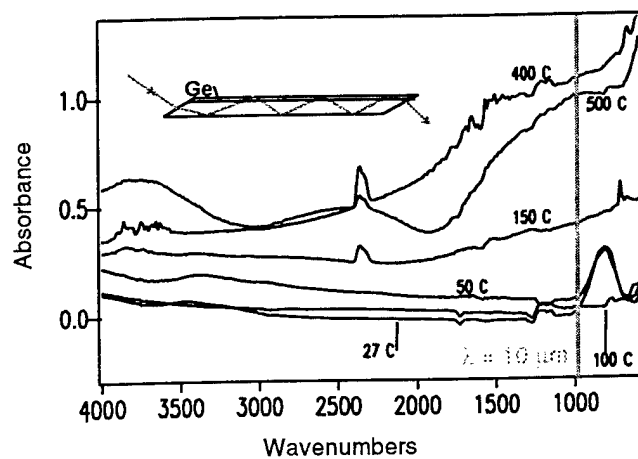
$RC = 400 \text{ psec}$

Bulk Modulator Response

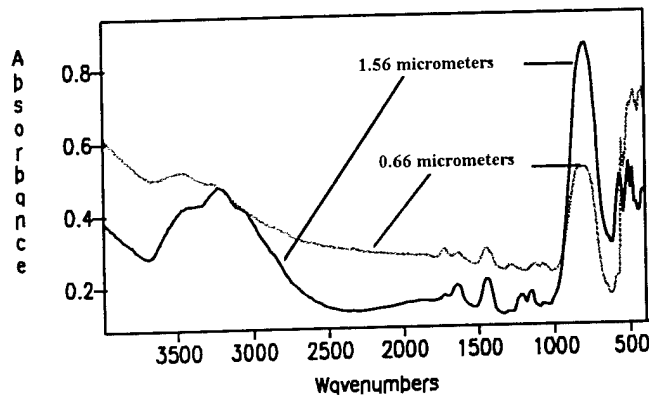


Demonstrated Risetime $\ll 10 \text{ nsecs}$
(limited by Function Generator and Detector)
A 20 volt, 100 nsec wide electrical pulse was applied.

Ge Epitaxy Absorption Loss
versus
Substrate Temperature During Evaporation



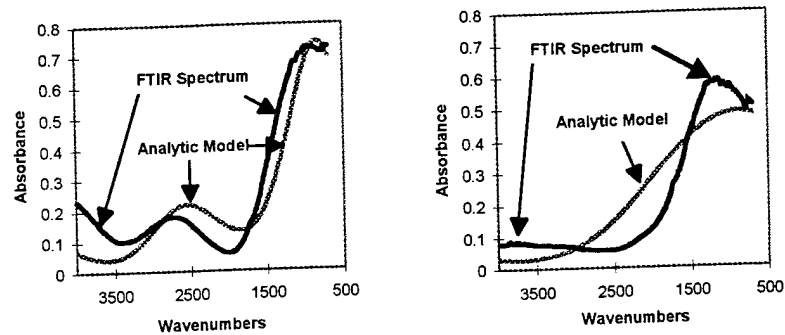
Low Temperature Ge Growth



The absorption peak at 830 cm^{-1} decreases in proportion to the thickness of the sample when etched, indicating a bulk effect. This is now believed to be from incorporation of Ge Oxide.

The absorption peak at 830 cm^{-1} for the films grown at RT and $50\text{ }^{\circ}\text{C}$ decreases in proportion to a 68% decrease in Ge film thickness via a chemical etch, indicating the features are from a bulk effect. The broad peak at 3200 cm^{-1} has a similar behavior. This spectrum was also found to be polarization independent.

High Temperature Ge Growth

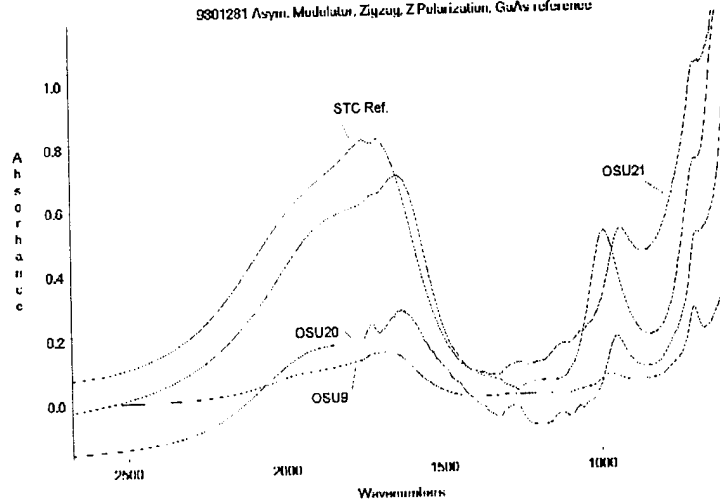


As the high temperature sample is etched, the magnitude of the absorption stays constant, but the oscillation frequency changes. This is expected from a thin polarized absorber at the Ge/GaAs interface, likely to be free electrons from interdiffusion.

Figure 3. The absorption spectra for the UHV Ge film deposited at 500 C before, (a), and after, (b), removal of 54% of the Ge film from 1.15 mm to 0.53 mm. using a chemical etch. The much-less-than-linear thickness dependence in the magnitude of the Absorbance indicates this absorption is from an interface. The oscillations in wavelength are expected for a polarization dependent thin film absorber because of interference of the total internally reflected beams. Fig. 3(a) shows the measured and analytic multilayer interference model for a thin birefringent layer at the Ge/GaAs interface. The absorption is taken to be birefringent with a Drude model laterally and an intersubband in the confinement direction. The analytic model required a Ge thickness of 0.97 mm to position the spectral peaks and valleys at the wavenumbers as shown whereas the actual thickness was measured to be 1.15 mm. The analytic curve in Fig. 3(b) uses the same model parameters as for 3(a), but with a Ge thickness of 0.47 mm, close to the measured 0.53 mm thickness of Ge film obtained after chemical etching. Note the observed change in spectral behavior is also qualitatively similar to that expected for a thin birefringent absorber at the Ge/GaAs interface.

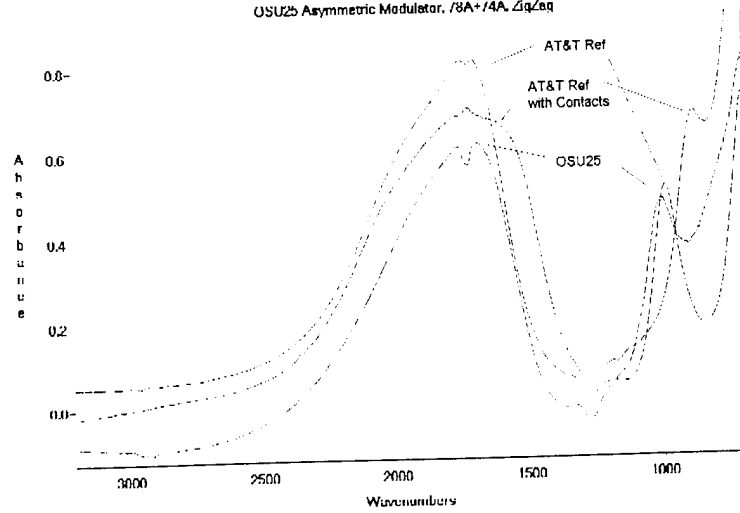
Ohio State MBE of Modulator

9901281 Asym. Modulator, Zigzag, Z Polarization, GaAs reference

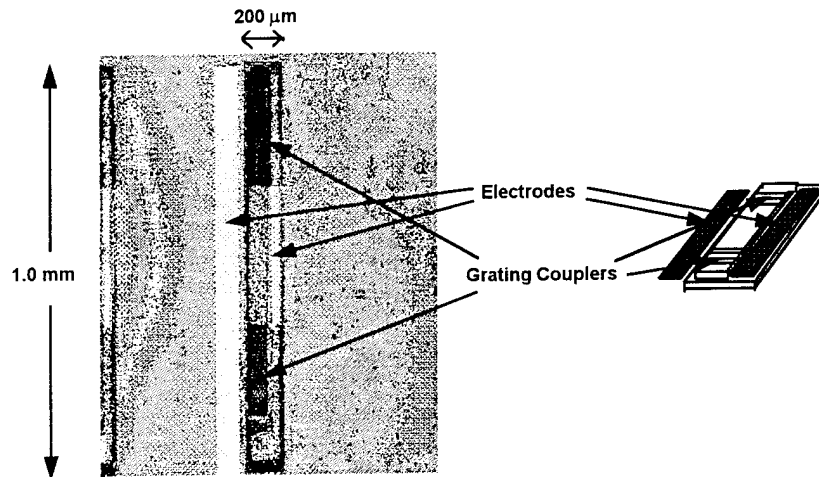


Ohio State MBE vs. AT&T

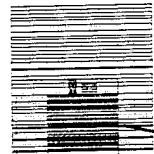
OSU25 Asymmetric Modulator, /8A+/4A, Δq/2q



Slab Waveguide Modulator

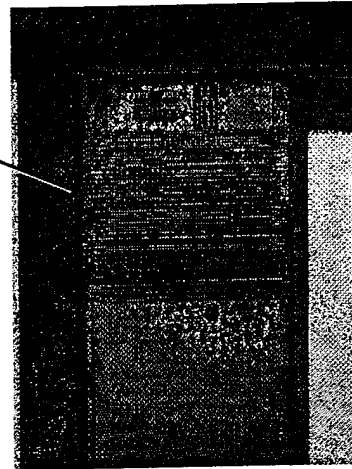


Slab Modulator with Gaussian Coupler

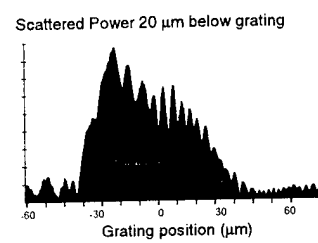
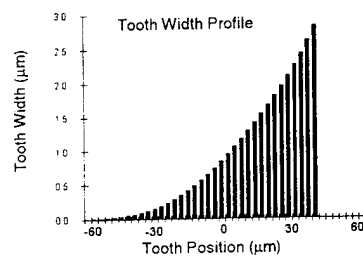
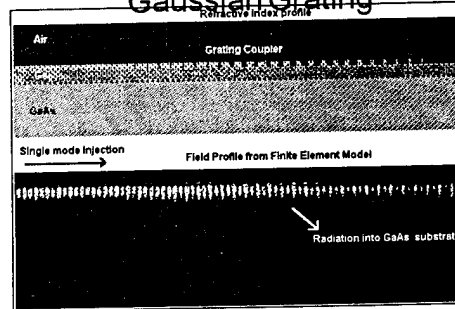


Beam Deflector
(on back side)

Gaussian Coupler

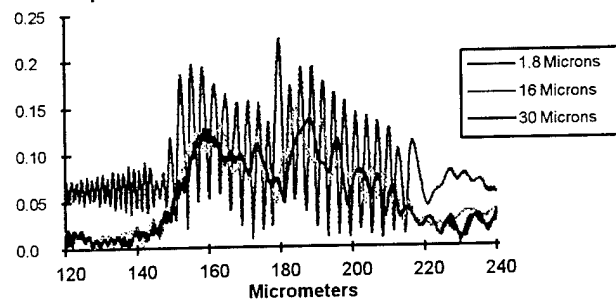


Gaussian Grating

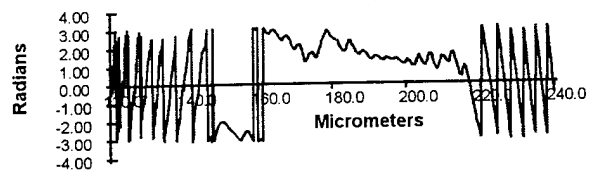


FEM Amplitude Plot

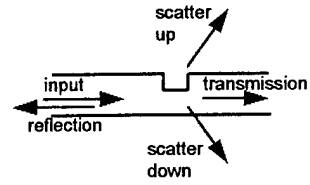
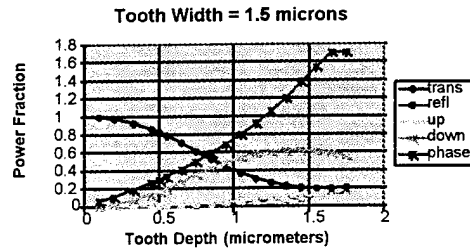
Amplitude of Scattered Light at Several Distances from Grating



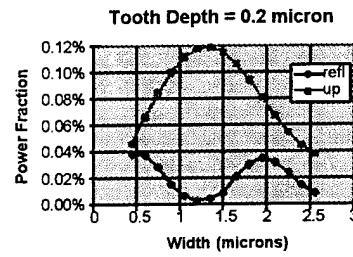
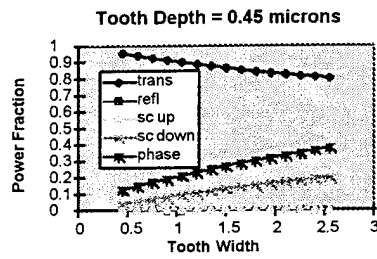
Phase of Output Beam



Coupling per Tooth

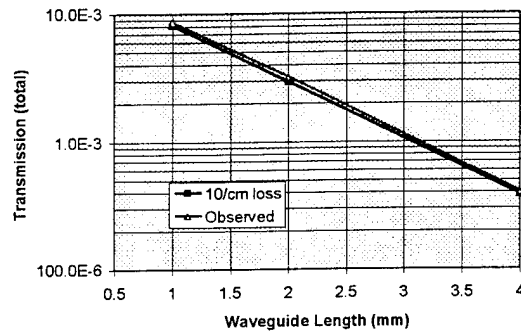


Note tooth reflection has a minimum around 1.2 microns.



Slab Waveguide Performance

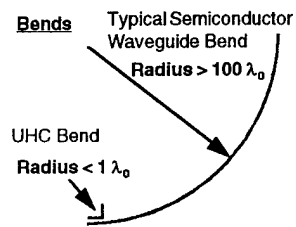
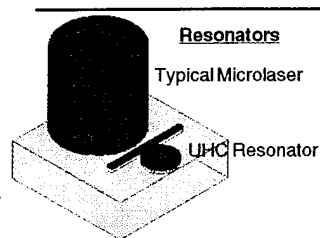
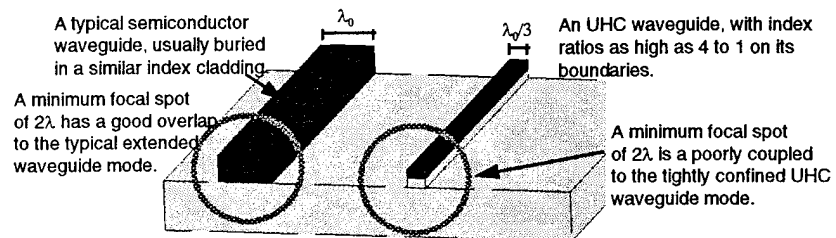
Ge Waveguide Loss per Length



Efficiency	Expected	Observed
Delta n (Fresnel)	0.8	0.8
Beam Deflector	0.65	0.35
Gaussian Grating	0.55	0.54
Single Couple	0.286	0.152
Double Couple	0.082	0.023

Ultra High Confinement Integrated Optics

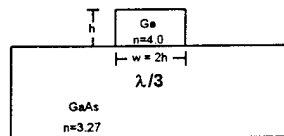
- Dramatically improved opto-electronic device performance.
- Very Large Scale Integrated Optics (VLSIO)



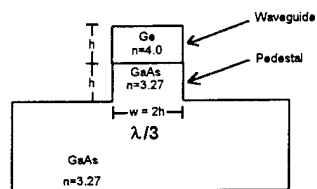
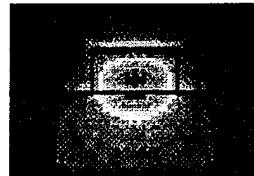
Ultra High Confinement Waveguides

Cross Sectional Area $< 0.1 \lambda^2$

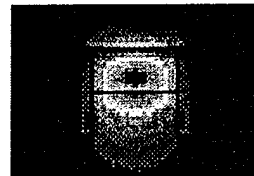
Vertical component of electric fields.
(from Finite Element Modeling)



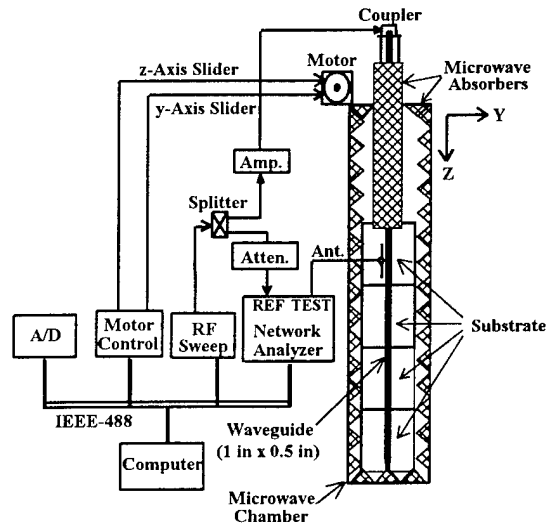
Rectangular Waveguide



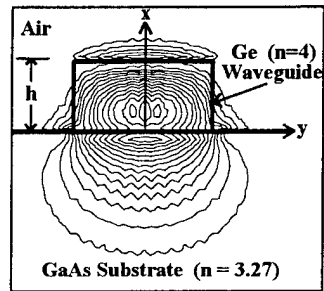
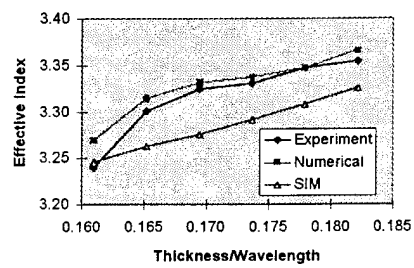
Pedestal Waveguide



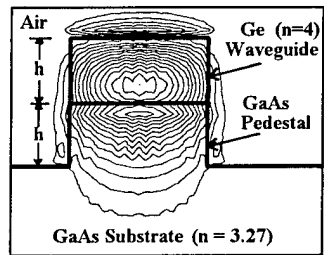
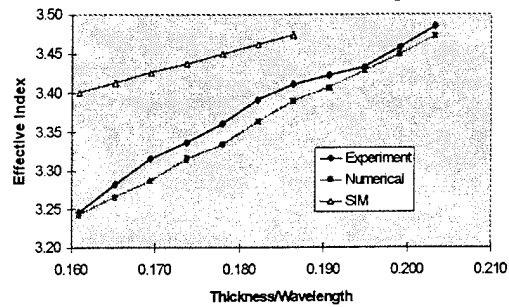
Microwave Scale Waveguide Experiments

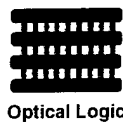


Effective Index for Ridge Waveguide

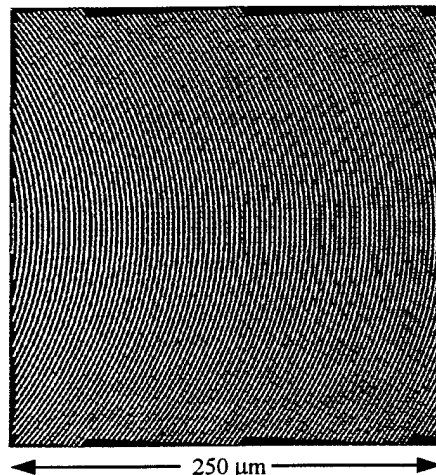
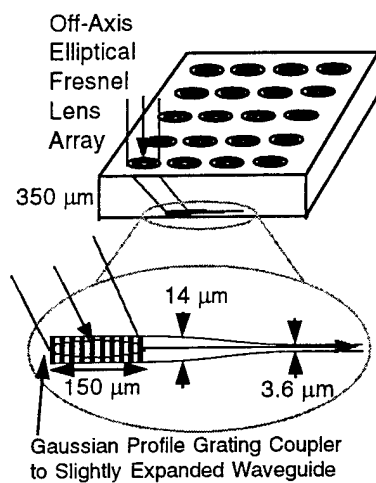


Effective Index for Pedestal Waveguide





Coupling into Waveguides

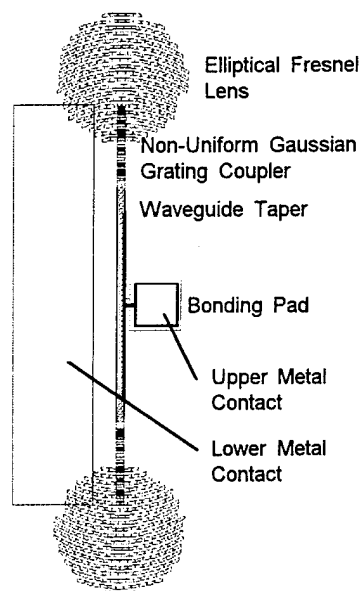
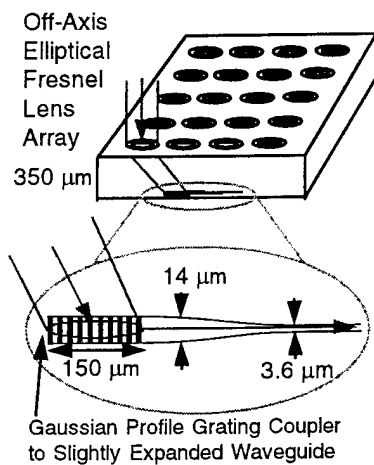


Off-Axis Elliptical Fresnel Lens



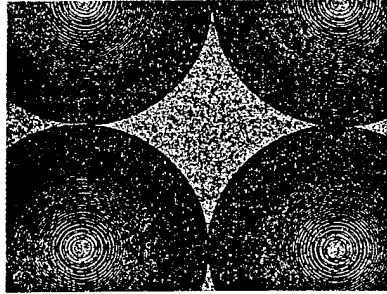
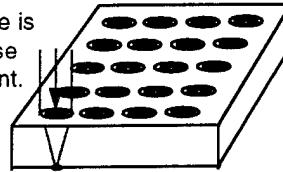
Optical Logic

An UHC Modulator:

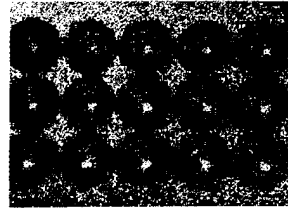


Through-Wafer Alignment

CO₂ laser beam at normal incidence is used to create burn spots on reverse side of wafer for back-side alignment.



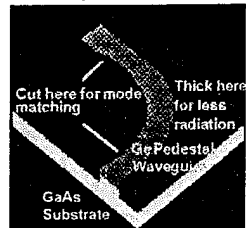
Fresnel Lenses



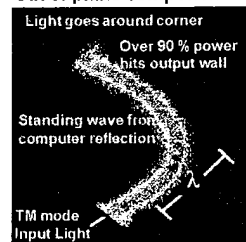
Focusing
Near-IR
White Light

Bends and Resonators

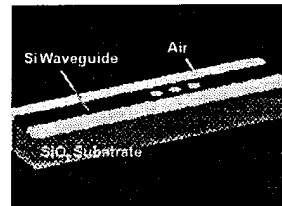
Tapered Width



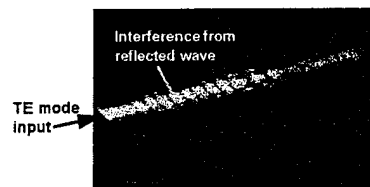
Electric field amplitude for out of plane component



Si on SiO₂ Resonator



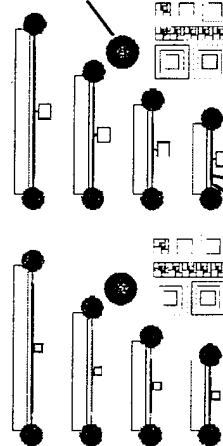
TE Mode Reflection



Low loss reflection indicates a cavity with a $Q > 100$ is possible

UHC Waveguide Modulator

Through-Wafer Alignment Lens



Alignment Marks and
Depth Gauges

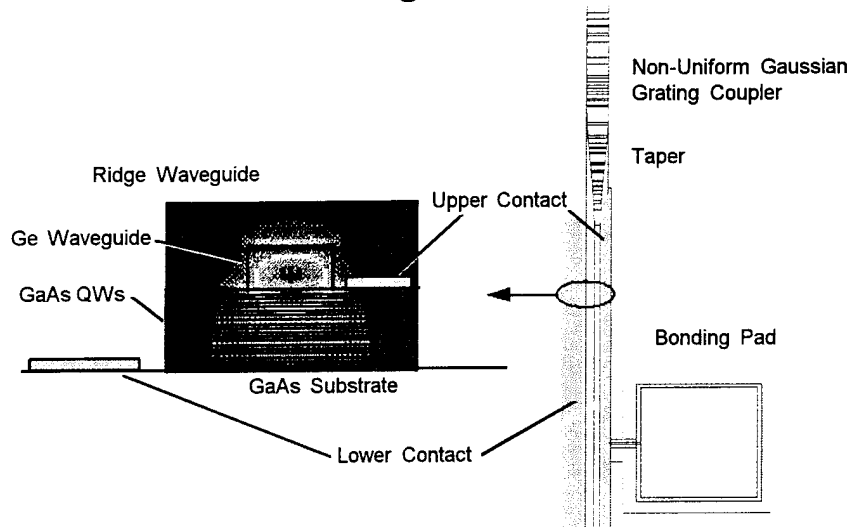
Elliptical Fresnel Lens

Wire Bonding Pad

UHC Waveguide

Gaussian Grating and
Taper

Active UHC Waveguide



Electronic Logic

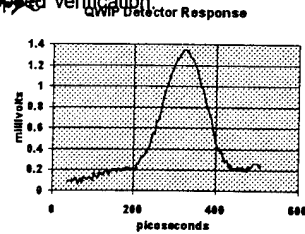
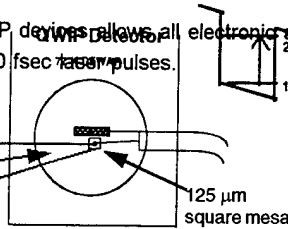
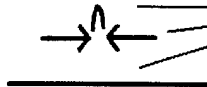


Detector

Detector Physics and System Test

- High speed QWIP devices allow all electronic speed verification
- Calibrate with 100 fsec laser pulses.

$\lambda = 9.3 \mu\text{m}$
100 fsec



High Speed Modulator Evaluation:

